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U. S. PATENT DOCUMENTS					
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FOREIGN PATENT DOCUMENTS					
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS
Translation YES NO					
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)					
X5	Toshihiko Ishihara & Igor Fomenkov, Excimer laser design for step-and-scan exposure tools, in MICROLITHOGRAPHY WORLD, Winter 1997, pages 21, 22, 24 and 25				
X7	Kazuaki Suzuki, Shinji Wakamoto & Kenji Nishi, KrF step and scan exposure system using higher N.A. projection lens, in SPIE, Vol. 2726, pages 767-779				
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